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04-12-2006 Sheila Hart (Signature)



PATENT

Attorney Docket No.: 006915/P07

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Kenneth COLLINS, et al.

Serial No.: 10/646,527

Examiner: Maureen G. Arancibia

Filed: August 22, 2003

Group Art Unit: 1763

For: PLASMA IMMERSION ION IMPLANTATION SYSTEM INCLUDING  
A PLASMA SOURCE HAVING LOW DISSOCIATION AND LOW MINIMUM  
PLASMA VOLTAGE

AMENDMENT UNDER 37 C.F.R. 1.111 TRANSMITTAL

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

SIR :

Transmitted herewith is an Amendment under 37 CFR 1.111 in response  
to the Office Action dated January 13, 2006 in the above-identified application. The  
fee has been calculated as shown below.

Claims remaining after amendment	Highest number previously paid for	Present extra	Rate	Additional Fee
Total Claims	25 minus 23 = 2		x \$50	\$100.00
Independent	2 minus 3 = 0		x \$200	\$000.00
If Multiple Dependent Claims Are Present, Add \$360.00				

**Total additional fee  
for this amendment** \$100.00

- No additional fee is required.
  - A check in the amount of \$ is attached.
  - The Commissioner is hereby authorized to charge payment of the fees in the amount of \$100.00 associated with this communication to Deposit Account No. 50-0338. The Commissioner is hereby authorized to charge any additional fees or deficiencies or credit overpayment to Deposit Account No. 50-0338. A duplicate copy if this sheet is enclosed.

Respectfully submitted,

Robert McNamee

Dated: April 12, 2006

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04/12/2006 J. Kelly, Jr.  
Date Name

PATENT

Attorney Docket No.: 006915/P07



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of :  
Kenneth COLLINS, et al. :  
  
Entitled: PLASMA IMMERSION ION : Group Art Unit: 1763  
IMPLANTATION SYSTEM INCLUDING A :  
PLASMA SOURCE HAVING LOW :  
DISSOCIATION AND LOW MINIMUM PLASMA: :  
VOLTAGE :  
  
Serial No.: 10/646,527 : Examiner: Maureen G.  
: Arancibia  
  
Filing Date: August 22, 2003 :  
:

**AMENDMENT UNDER 37 CFR 1.111**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated January 13, 2006,  
please amend the above-identified patent application as follows:

**Amendments to the Claims** are reflected in the listing of claims  
which begins on page 2 of this paper.

**Remarks/Arguments** begin on page 9 of this paper.

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